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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/616,076 Confirmation No. 4322  
Applicant : M. ISHIBASHI et al  
Filed : July 13, 2000  
Title : PROBE FOR SCANNING PROBE LITHOGRAPHY AND  
MAKING METHOD THEREOF  
TC/AU : 2881  
Examiner : K.T. Nguyen  
Docket No. : NIT-207  
Customer No.: 24956

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NOTICE OF NON-COMPLIANT  
AMENDMENT (37 CFR §1.121)**

Sir:

In response to the Notice of Non-Compliant Amendment of April 24, 2006,  
Applicants submit the following complete listing of the claims and remarks submitted  
on December 13, 2001.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page 2 of this paper.

**Amendments to the Drawings** begin on page 10 of this paper and include both an  
attached replacement sheet and an annotated sheet showing changes.

**Remarks / Arguments** begin on page 11 of this paper.

**Appendix** including amended drawing Fig. 12(a) is attached following page 14 of  
this paper.